

Docket No. 0163-0707-2X

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kenji MIWA, et al.

GROUP ART UNIT:

SERIAL NUMBER: New Application

EXAMINER:

FILED: HERewith

FOR: METHOD OF REFINEMENT OF MICROSTRUCTURE OF METALLIC MATERIALS

REQUEST FOR PRIORITY UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the applicants
claim as priority:

COUNTRY

APPLICATION NO:

MONTH/DAY/YEAR

Japan

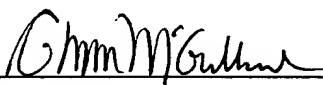
9-275330

September 22, 1998

A Certified copy of the corresponding Convention Application will be submitted prior to payment of
the Final Fee.

Respectfully submitted,

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